IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Young-Kwan Lee, et al.		
Serial No Pending	Filing Date: January 27, 2004		
Title of Application:	Antenna Structure For Inductively Coupled Plasma Generator		

Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents enclosed).

U.S. Patent Documents								
Exam. Initials	Class/ Subclass.	Document No.			Date	Name		
	376/123	5,289,509			1994	Moeller		
Foreign Patent Documents								
Exam. Initials	Document No.		Date			Country		
	1 079 6	71	2001		EP			
	2000-323298		2000		JP (witl	h English abstract)		
	2000-048998		2000		JP (with English abstract)			

The listed patents pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

January 27, 2004	Respectfully submitted, H. J. Park				
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Date Considered	Examiner				